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# **Future Trends in Ultra-Precision Machining**

Guest Editors:

## Dr. Changlin Liu

State Key Laboratory of Ultraprecision Machining Technology, Department of Industrial and Systems Engineering, The Hong Kong Polytechnic University, Hong Kong 999077, China

### Prof. Dr. Yanbin Zhang

School of Mechanical and Automotive Engineering, Qingdao University of Technology, Qingdao 266520, China

#### Dr. Xiaoliang Liang

Key Laboratory of High Efficiency and Clean Mechanical Manufacture, Ministry of Education, School of Mechanical Engineering, Shandong University, Jinan 250000, China

Deadline for manuscript submissions:

31 August 2025

## **Message from the Guest Editors**

Ultra-precision machining is a multi-disciplinary research area, which forms the backbone and support of today's innovative technology industries. including optoelectronics, aerospace, optics, and biomedical engineering. With the rapid development of these industries, surface quality requirements of manufacturing products become more and more stringent. In order to make the surface finishing adapt to this new situation, the exploration of new mechanisms and technologies has become a great interest of research. This Special Issue aims to publish original research and review articles in the field of "Future Trends in Ultra-Precision Machining". Papers on new theories, techniques, and applications in the fields of ultra-precision machining are welcome. Suitable topics include but are not limited to new mechanisms of processes involving material removal, the scientific development of new processes, surface topography measurement, and novel concepts in ultra-precision machining supported by modelling and experiments. We also welcome scholars in related fields to contribute their latest research results to this Special Issue.











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## **Editor-in-Chief**

#### Prof. Dr. Ai-Qun Liu

1. Department of Electrical and Electronic Engineering, The Hong Kong Polytechnic University, Hong Kong, China 2. School of Electrical and Electronic Engineering, Nanyang Technological University, Singapore 639798, Singapore

# Message from the Editor-in-Chief

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